



Attorney Docket No. 51876.P542

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Patent Application of:

**Tae-Woo Jung et al.**

Serial No. 10/750,021

Filed: December 30, 2003

For: **METHOD FOR FABRICATING  
SEMICONDUCTOR DEVICE HAVING  
TRENCH TYPE DEVICE ISOLATION  
LAYER**

Examiner: Quovaunda Jefferson

Art Unit: 2823

*Submission  
w/PEX  
8/10/03  
[Signature]*

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION**

Dear Commissioner:

In response to the Final Office Action mailed May 17, 2005, regarding the above-referenced application, Applicant respectfully requests entry of the amendment set forth below in consideration of the remarks that follow.